

<b>L Number</b>	<b>Hits</b>	<b>Search Text</b>	<b>DB</b>	<b>Time stamp</b>
<b>1</b>	<b>26335</b>	<b>((micro or fine or electro adj static or electrostatic) adj2 (position\$3 or actuation or actuator\$1)) or microactuat\$3 or microposition\$3 or piezo adj2 electric\$1 or piezoelectric or PZT or lead adj zirconium adj titanate or microelectromechanical or MEMS or micro adj electro adj mechanical or bimorph or monomorph or electrostrict\$5) and (g11b\$.ipc. or record\$3 or reproduc\$5 or slider or transduc\$5 or dasd or direct adj access adj storage or memory or disk\$1 or disc\$1)</b>	<b>EPO; JPO; DERWENT</b>	<b>2003/05/14 08:39</b>
<b>2</b>	<b>14575</b>	<b>flexure or gimbal</b>	<b>EPO; JPO; DERWENT</b>	<b>2003/05/14 08:39</b>
<b>3</b>	<b>262</b>	<b>((((micro or fine or electro adj static or electrostatic) adj2 (position\$3 or actuation or actuator\$1)) or microactuat\$3 or microposition\$3 or piezo adj2 electric\$1 or piezoelectric or PZT or lead adj zirconium adj titanate or microelectromechanical or MEMS or micro adj electro adj mechanical or bimorph or monomorph or electrostrict\$5) and (g11b\$.ipc. or record\$3 or reproduc\$5 or slider or transduc\$5 or dasd or direct adj access adj storage or memory or disk\$1 or disc\$1)) and (flexure or gimbal)</b>	<b>EPO; JPO; DERWENT</b>	<b>2003/05/14 09:08</b>
<b>4</b>	<b>332</b>	<b>((micro or fine or electro adj static or electrostatic or two adj stage or dual) adj2 (position\$3 or actuation or actuator\$1)) or microactuat\$3 or microposition\$3 or piezo adj2 electric\$1 or piezoelectric or PZT or lead adj zirconium adj titanate or microelectromechanical or MEMS or micro adj electro adj mechanical or bimorph or monomorph or electrostrict\$5) and (record\$3 or reproduc\$5 or slider or transduc\$5 or dasd or direct adj access adj storage or memory or disk\$1 or disc\$1)</b>	<b>IBM_TDB</b>	<b>2003/05/14 09:13</b>
<b>5</b>	<b>844</b>	<b>hsa or hga or load adj beam or suspension or flexure or gimbal</b>	<b>IBM_TDB</b>	<b>2003/05/14 09:14</b>

6	23	(((micro or fine or electro adj static or electrostatic or two adj stage or dual) adj2 (position\$3 or actuation or actuator\$1)) or microactuat\$3 or microposition\$3 or piezo adj2 electric\$1 or piezoelectric or PZT or lead adj zirconium adj titanate or microelectromechanical or MEMS or micro adj electro adj mechanical or bimorph or monomorph or electrostrict\$5) and (record\$3 or reproduc\$5 or slider or transduc\$5 or dasd or direct adj access adj storage or memory or disk\$1 or disc\$1)) and (hsa or hga or load adj beam or suspension or flexure or gimbal)	IBM_TDB	2003/05/14 09:09
7	650	(((micro or fine or electro adj static or electrostatic or two adj stage or dual) adj2 (position\$3 or actuation or actuator\$1)) or microactuat\$3 or microposition\$3 or piezo adj2 electric\$1 or piezoelectric or PZT or lead adj zirconium adj titanate or microelectromechanical or MEMS or micro adj electro adj mechanical or bimorph or monomorph or electrostrict\$5) and (record\$3 or reproduc\$5 or slider or transduc\$5 or dasd or direct adj access adj storage or memory or disk\$1 or disc\$1)).ti.ab.	USPAT; US-PGPUB	2003/05/14 09:14
8	1354	(ceramic or silicon or hsa or hga or load adj beam or suspension or flexure or gimbal).ti,ab.	IBM_TDB	2003/05/14 09:15
9	101475	(ceramic or silicon or hsa or hga or load adj beam or suspension or flexure or gimbal).ti,ab.	USPAT; US-PGPUB	2003/05/14 09:16
10	111	(((micro or fine or electro adj static or electrostatic or two adj stage or dual) adj2 (position\$3 or actuation or actuator\$1)) or microactuat\$3 or microposition\$3 or piezo adj2 electric\$1 or piezoelectric or PZT or lead adj zirconium adj titanate or microelectromechanical or MEMS or micro adj electro adj mechanical or bimorph or monomorph or electrostrict\$5) and (record\$3 or reproduc\$5 or slider or transduc\$5 or dasd or direct adj access adj storage or memory or disk\$1 or disc\$1)).ti.ab.) and ((ceramic or silicon or hsa or hga or load adj beam or suspension or flexure or gimbal).ti,ab.)	USPAT; US-PGPUB	2003/05/14 09:17